

Attorney Docket No.: SAM-0422

E UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Sang-don Yi

U.S. Serial No.:

10/600,724

Filing Date:

June 20, 2003 Mai, Anh D.

Examiner: Group Art Unit:

2814

Date of Notice of Allowance:

December 20, 2004

Title:

SILICON-ON-INSULATOR WAFER AND METHOD OF

MANUFACTURING THE SAME

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1-24-05

Date

Vanessa Marakas

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- [] under 37 CFR 1.129(a), or (First/Second submission after Final Rejection)
- [] under 37 CFR 1.97(b), or
 (Within three months of filing national application other than a CPA under §1.53(d); or within
 three months of date of entry of the national stage in international application; or before mailing date of first
 Office Action on the merits; or before mailing date of first Office Action after filing RCE under §1.114,
 whichever occurs last)
- [] under 37 CFR 1.97(c) together with either:
 - [] a Statement under 37 CFR 1.97(e), as checked below, or
 - [] the \$180.00 fee under 37 CFR 1.17(p), or (After the 37 CFR 1.97(b) time period, but before final action or notice of allowance, or other action which closes prosecution, whichever occurs first)
- [X] under 37 CFR 1.97(d) together with:
 - [X] a Statement under 37 CFR 1.97(e), as checked below, and
 - [X] the \$180.00 fee set forth in 37 CFR 1.17(p).

 (Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

180,00 00

01/28/2005 ANABII 00000005 10600724

Applicant(s): Sang-don Yi U.S. Serial No.: 10/600,724



Statement Under 37 C.F.R. 1.97(e)

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement.

Enclosed herewith is form PTO-1449:

	Copie	s of cited references are enclosed.						
[]		es of cited references are enclosed except those entered in prior application, U.S. No, and references that are not required to be submitted under 37 1.98.						
[]	The lis	ne listed references were cited in a counterpart foreign application.						
Conci	se Expl	anation Requirement (non-English references):						
[X]	The "concise explanation" requirement under 36 CFR 1.98(a)(3)(i) for references AL-AN is satisfied by:							
	[]	the explanation provided on the attached sheet.						
	[]	the explanation provided in the Specification.						
	[X]	submission of related U.S. Patent No. 6,242,320 (Reference AN).						
	[X]	abstract (References AL-AN).						

It is requested the information disclosed herein be made of record in this application.

Applicant(s): Sang-don Yi U.S. Serial No.: 10/600,724

Method of payment:

Enclosed is a check in the amount of \$180.00. [X][] Please charge Deposit Account of 50-1798 in the amount of _

[] Two duplicate copies of this Statement are enclosed.

[X] Please charge any deficiency in fees and credit any overpayment to Deposit Account No. 50-1798.

Respectfully submitted,

Anthony P. Onello, Jr.

Attorney for Applicants

Registration Number 38,572

Mills & Ohello, LLP

Eleven Beacon Street, Suite 605 Boston, Massachusetts 02108

Telephone: (617) 994-4900 Facsimile: (617) 742-7774

J:\SAM\0422\IDS\IDSform.wpd

-3-

PATENT

O , Se sone sign

Attorney Docket No.: SAM-0422

Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Sang-don Yi

U.S. Serial No.:

10/600,724

Filing Date:

June 20, 2003

Examiner:

Mai, Anh D.

Group Art Unit:

2814.

Date of Notice of Allowance:

December 20, 2004

Title:

SILICON-ON-INSULATOR WAFER AND METHOD OF

MANUFACTURING THE SAME

CERTIFICATE OF MAILING UNDER 37 C.F.R.§ 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1-24-05

Vanessa Marakas

Date

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

- 1. Information Disclosure Statement;
- 2. Form PTO-1449 and copies of cited references AA and AL-AN; and
- 3. Check in the amount of \$180.00 to cover fee under 37 CFR 1.17(p); and
- 4. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. <u>A duplicate copy of this letter is provided for this purpose</u>.

Respectfully submitted,

Mills & Opello, LLP

Mills & Opello, Lale

Eleven Beacon Street, Suite 605 Boston, Massachusetts 02108

Telephone: (617) 994-4900 Facsimile: (617) 742-7774 J:\SAM\0422\IDS\transIDS.wpd

Anthony P. Onello, Jr.

Registration Number 38,572 Attorney for Applicants

FORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

SAM-0422	10/600,724				
Applicant Sang-don Yi					
Filing Date 06/20/03	Group Art Unit 2814				

EXAMINER		DOCUMENT				****	FILING D	DATE
INITIALS	AA	NUMBER	DATE	NAME	CLASS	SUBCLASS 406	if appropriate 11/08/99	
	 	6,242,320	06/05/01	So	438	400	11/08	199
	AB							
	AC	•						
	AD		 	,				
	AE							
	AF		 					
	AG	·	 					
	AH							
	AI						_	
	AJ		ļ					
 	AK							
			FOREIGN	PATENT DOCU	JMENTS			
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Transla YES	tion N
	AL	4-3910	01/08/92	Japan	G01L	21/02		λ
	AM	7-231036	08/29/95	Japan	H01L	21/762		>
	AN	00-183157	06/30/00	Japan	H01L	21/762		>
	AO							
	AP							
	AQ							
		OTHER:	DOCUMEN	TS (Including A	uthor, Title, 1	Date, Pertine	nt Pages,	, Etc
	AR							
	AS							
	AT	· ·	·		·			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.